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Applicant

Mark Philip D'Evelyn et al.

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Group 2812

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
W.SC.	/A1	5,637,531	6/10/97	Porowski et al.			
	A2	5,770,887	6/23/98	Tadatomo et al.			
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	A4					,	
	A5						
	A6						

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		DOCUMENT					TRANSL	
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، ساکالن	₽Ď1	WO 95/04845	2/16/95	PCT				
VSC	√B2	EP 0 937 790	8/25/99	European				

## OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, etc.)

WS		C1	Elsevier, Materials Science & Engineering B44, "Growth and Properties of Single Crystalline GaN Substrates and Homoepitaxial Layers", S. Porowski, pages 407-413, 1997.
	1	C2	Elsevier, Diamond and Related Materials, "AMMONO Method of GaN and AIN Production", R. Dwilinski et al., Volume 7, pages 1348-1350, 1998.
	1	C3	MRS Internet Journal of Nitride Semiconductor Research, "Near Defect Free GaN Substrates", S. Porowski, Volume 4S1, G1.3, 1999.
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	L	C5	Materials Research Society Symp. Proc., "Materials Chemistry and Bulk Crystal Growth of Group III Nitrides in Supercritical Ammonia", Joseph W. Kolis et al., Volume 495, pages 367-372, 1998.
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		C7	Application RD-27,007 – "Crystalline Gallium Nitride and Method for Forming Crystalline Gallium Nitride".
V	,	C8	Application RD-27,904 - "Homoepitaxial Gallium-Nitride-Based Light Emitting Device and Method for Producing".

**EXAMINER** 

DATE CONSIDERED

7/16/02

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant